Electronic Paten	t App	lication Fee	Transm	ittal			
Application Number:	106	10650087					
Filing Date:	28-	28-Aug-2003					
Title of Invention:		Substrate treatment device, substrate treatment method, and cleaning method for substrate treatment device					
First Named Inventor/Applicant Name:	Tac	Tadahiro Ishizaka					
Filer:	Chi	Christopher Michael Tucker/Monique Logan					
Attorney Docket Number:	070	070120-0305185					
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total ir USD(\$)		
Basic Filing:					I		
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Post-Allowance-and-Post-Issuance: Extension-of-Time:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)				
Miscellaneous:								
Request for continued examination	1801	1	810	810				
	Tot	940						